

AMENDMENTS TO THE CLAIMS:

Please cancel Claims 2 through 41 without prejudice to or disclaimer of the subject matter recited therein.

1. (Original) A method of fabricating an aspherical microstructure, said method comprising the steps of:

- (a) forming a protruding microstructure in a recess on a substrate;
- (b) forming an aspherical-profile forming layer on the substrate and the protruding microstructure, an aspherical profile being formed on the protruding microstructure utilizing a surface tension of the aspherical-profile forming layer; and
- (c) hardening the aspherical-profile forming layer with the aspherical profile being maintained.

Claims 2 through 41 (Cancelled).